. L	Number Hit		Search Text (h011021/\$.ipc. and (work or susceptor) and conduct\$4 and insulat\$4 and ((silicon	DB JPO; DEFWENT	Time stamp 2002/07/25 13:43
	11:	26	adj parbide) or titanium)).CCLS. h011021/\$.ipc. and (work or susceptor) and conduct\$4 and insulat\$4 and ((silicon adj carbide) or titanium)	USFAT; US-FGPUB	20/07/16/17 16:43
-	9	96	(.011021/\$.ipc. and (work or susceptor) and conduct\$4 and insulat\$4 and ((silicon add carbide) or titanium)) and (uv or (ultra add violet))	USFAT; US-PGPUB	2000/06/17 16:33
-	11	1.7	(h0ll001/\$.ipc. and (work or susceptor) and conduct\$4 and insulat\$4 and ((silicon adj carbide) or titanium)) and static and	USFAT; US-PGPUB	2002 (06/17 16:39
-			gas h011021/\$.ipc. and (work or susceptor) and conduct\$4 and insulat\$4 and ((silicon adj carbide) or titanium)	CPO; DEFWENT	2002 9 6-17 16:51
-		7	h0110.1/\$.ipc. and (work or susceptor or pedestal) and conduct\$4 and insulat\$4 and ((sillcon adj carbide) or titanium)	JPI; DEFWENT	2012/05/17 16:52
-	5.4		h011021/\$.ipc. and (work or susceptor or pedestal) and conduct\$4 and insulat\$4	JPO; DERWENT	2002/16:17 16:53
-		20	hullD_1/\$.ipc. and (work or susceptor or pedestal) and conduct\$4 and insulat\$4 and (sil:com or titanium)	JPO; DEFWENT	2002706 17 17:02
-	:		hull0.1/\$.ipc. and ((work adj table) or susceptor or pedestal or (work adj hilder): and conduct\$4 and insulat\$4 and (silicon or titanium)	JPO; DEPWENT	2002/05/17 17:39
-	5.		h011031/\$.ipc. and ((work adj table) or susceptor or pedestal or (work adj h.1der. and conduct\$4	JPO; DEPWENT	2002/06/17 17:42
-	21	27	hell)_1:\$.ipc. and ((work adj table) or susceptor or pedestal or (work adj helder)) and (conduct\$4 or (conductive adj film::. and gas\$2	JPO; DEFWENT	2002 6:17 10:44
-	2.:		h011021/\$.ipc. and ((work adj table) or susceptor or pedestal or (work adj h01der)) and (conduct\$4 or (conductive adj film);and gas\$2	JPO; DEFWENT	2000.07:23 16:11
-		-	<pre>(m011021/\$.ipc. and ((work adj table) or susceptor or pedestal or (work adj holder) and (conduct\$4 or (conductive adj film;;and gas\$2) and static</pre>	JPO; DEFWENT	20 (2, () ² (24, 13:34)
-	õ	93	c.3c016/\$.ipc. and ((work adj table) or susceptor or pedestal or (work adj holder): and (conduct\$4 or (conductive adj film))and gas\$2	JPC; DERWENT	L00Ly06 17 17:55
-		(1	c23c016/\$.ipc. and ((work adj table) or susceptor or pedestal or (work adj holder): and (conduct\$4 or (conductive adj film))and gas\$2 and static and ground\$3	JPO; DEPWENT	0000/06/17 18:41
-		(ı	<pre>(cd3c01f/\$.ipc. and ((work adj table) or susceptor or pedestal or (work adj holder): and (conduct\$4 or (conductive adj</pre>	JPO; DEFWENT	2002/06/17 17:57
-		Ģ	<pre>film:)and gas\$1) and ground\$3 and static (023c016/\$.ipc. and ((work adj table) or susceptor or pedestal or (work adj helder)) and (conduct\$4 or (conductive adj film))and gas\$1) and ground\$3</pre>	JPO; DERWENT	2002/06/17 18:21
-	6		156/345.5.cols.	USPAT; US-PGFUB	1000,00017 18:03
-	1		156/345.5.ccls. and conduct\$3 and insulat\$3	USPAT; US-PGFUB	2001,06,17 18:14
-	3		118/\$.ccls. and ((work adj table) or susceptor or pedestal or (work adj holder)) and (conduct\$4 or (conductive adj film))and gas\$2 and static and ground\$3	USPAT; US-PGFUB	2002/07/24 14:05

		_	_	
-	287	118'\$.ccls. and ((work adj table) or susceptor or pedestal or (work adj holder) or (substrate adj holder)) same ((silicon adj carbide)or SiC or titanium)and gas\$2	USPAT; US-PGPUB	2002'06'18 15:41
-	1	5904 78.pn.	USPAT;	2002 06/18 10:12
-	218	118/\$.ccls. and ((work adj table) or susceptor or pedestal or (work adj holder) or (substrate adj holder)) same ((silicon adj carbide) or Sid or (titanium adj txide)) and gas\$2	US-PGPUB USPAT; US-PGPUB	20)2 07 23 16:07
-	218	(118-8.cols. and ((work adj table) or susceptor or pedestal or (work adj holder) or (substrate adj holder)) same ((silicon adj carbide) or SiC or (titanium adj exide)) and gas\$2) and (conduct\$4 or gas or ground\$3)	USPAT; US-P3PUB	200. 06/18 14:13
-		(156-345.82).ccls. and ((work adj table) or susceptor or pedestal or (work adj holder) or (substrate adj holder)) same ((silicon adj carbide)or SiC or (titanium adj oxide))and gas\$2	USPAT; US-PGPUB	2001/06/18 14:03
-	11	((156/345.\$2).ccls. and ((work adj table) or susceptor or pedestal or (work adj holder) or (substrate adj holder)) same ((silicon adj carbide) or Sil or (titanium adj oxide)) and gas\$1) not ((118/\$.ccls. and ((work adj table) or susceptor or pedestal or (work adj holder) or (substrate adj holder)) same ((silicon adj carbide) or Sil or (titanium adj oxide)) and gas\$1) and (tonduct\$4 or gas or ground\$3))	USPAT; US-PGPUB	2002/06/18 14:09
-		(tokyo adj electron).as.	USPAT; US-PGPUB	7000/06/18/14:10
-		<pre>((tckyo adj electron).as.) and ((work adj table) or susceptor or pedestal or (work adj holder) or (substrate adj holder)) same ((silicon adj carbide)or SiC or (titanium adj oxide))and gas\$2</pre>	USPAT; US-PGPUB	_2002+06 18 14:24
-	20	<pre>(((tckyo adj electron).as.) and ((work adj table) or susceptor or pedestal or (work adj holder) or (substrate adj holder)) same ((silicon adj carbide) or SiC or (titanium adj oxide)) and gas\$2) and (conduct\$4 or gas or ground\$3)</pre>	USPAF; US-PGPUB	.2002/06 18 14:25
-		<pre>((tckyo adj electron).as.) and ((work adj table) or susceptor or pedestal or (work adj holder) or (substrate adj holder))</pre>	USPAT; US-PGPUB	1002:06/18/14:05
-		<pre>(:(tokyo adj electron).as.) and ((work adj table) or susceptor or pedestal or (work adj holder) or (substrate adj holder))) and (conduct\$4 or gas or ground\$3)</pre>	USPAT; US-PGPUB	1002 06 18 14:48
-	20	<pre>(:(trkys adf slootron).io.) and ((work adj table) or susceptor or pedestal or (work adj holder) or (substrate adj holder))) and penduct%4 and ground\$3 and static</pre>	USPAT; US-PGPUB	1000,07 24 10:40
-		<pre>(:(tekyo adg electron).as.; and ((work adg table) or susceptor or pedestal or (work adg holder) or (substrate adg holder))) and conduct\$4 and ground\$3 and static) not electrostatic</pre>	USPAT; US-PGPUB	200 06,18 14:54
-	C	h011001/\$.ipc. and ((work adj table) or susceptor or pedestal or (work adj holder) or (substrate adj holder)) and conduct\$3 and static and ground\$2	JPO; DERWENT	2000/06/18 17:23
-	42	h011021/\$.ipc. and ((work adj table) or susceptor or pedestal or (work adj holder) or (substrate adj holder)) and conduct\$3 and ground\$2	JPO; DERWENT	2002/06/18 15:25

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-	6	h011021/\$.ipc. and ((work adj table) or susceptor or pedestal or (work adj holder) or (substrate adj holder)) and conduct\$3 and ground\$2 and (static or	JPO; DEFWENT	2002/06/18 15:37
_	1	charg⊬) 6J947U2.pn.	JPO;	2002 105 18 15:38
-	1	6194702.pn.	DEFWENT USPAT;	2 102 (05 (18 15:38
-	164	118/\$.ccls. and ((work adj table) or susceptor or pedestal or (work adj holder)) and (conduct\$4 or (conductive adj film), and gas\$2 and (static or charge) and	US-PGPUB USPAT; US-PGPUB	2002/06/18 15:45
-	34	ground\$3 118/\$.ccls. and ((work adj table) or susceptor or pedestal or (work adj helder)) and (conduct\$4 or (conductive adj film))and gas\$2 and static and ground\$3	USPAT; US-PGPUB	2002/06/18 15:49
-	130	(118/%.ccls. and ((work adj table) or susceptor or pedestal or (work adj holder)) and (conduct\$4 or (conductive adj film)) and gas\$2 and (static or charge) and ground\$3) not (118/%.ccls. and ((work adj table) or susceptor or pedestal or (work adj holder)) and (conduct\$4 or (conductive adj film)) and gas\$2 and static and ground\$3)	USPAT; US-P3PUB	2002/06/18 16:32
-	109	(:118/\$.ccls. and ((work adj table) or susceptor or pedestal or (work adj hilder) and (conduct\$4 or (conductive adj film)) and gas\$2 and (static or charge) and ground\$3) not :118/\$.ccls. and ((work adj table) or susceptor or pedestal or (work adj hilder)) and (conduct\$4 or (conductive adj film)) and gas\$2 and static and ground\$3)) and film	USFAT; US-PGPUB	.000.06-18 16:33
_		((118/\$.ccls. and ((work adj table) or susceptor or pedestal or (work adj holder)) and (conduct\$4 or (conductive adj film))and gas\$% and (static or charge) and ground\$3) not (118/\$.ccls. and ((work adj table) or susceptor or pedestal or (work adj holder)) and (conduct\$4 or (conductive adj film))and gas\$2 and static and ground\$3)) and conductiv\$2 with film	USFAT; US-PGPUB	200.006/18 16:35
-	45	((113/\$.ccls. and ((work adj table) or susceptor or pedestal or (work adj holder)) and (conduct\$4 or (conductive adj film))and gas\$2 and (static or charge) and ground\$3) not (118/\$.ccls. and ((work adj table; or susceptor or pedestal or (work adj holder)) and (conduct\$4 or (conductive adj film))and gas\$2 and static and ground\$3)) and (conductiv\$2 with film)	US-PGPUB	2002,06,18 16:36
-	6	hillOll/\$.ipc. and ((work adj table) or susceptor or pedestal or (work adj holder) or (substrate adj holder)) and conduct\$3 and (static or charge) and ground\$2	JPC; DERWENT	2002, 00, 18 17:25
-	32	118/\$.cols. and ((work adj table) or susceptor or pedestal or (work adj hilder) or (substrate adj holder) same ((sil:con adj carbide) or SiC or (titanium adj oxide)) and gas\$2 and (charge or static)	USPAT; US-PGPUB	0000/06/18 17:56
-	104	((work adj table) or susceptor or pedestal or (work adj holder) or (substrate adj holder)) same ((silicon adj carbide)er SiC or (t:tanium adj oxide))and gas\$2 and (charge or static)and (vacuum or exhaust)and conduct\$3	USPAT; US-PGPUB	2002/06/18 18:05

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_	57	((work adj table) or susceptor or pedestal or (work adj holder) or (substrate adj holder)) same ((silicon adj carbide)) or SiC or (titanium adj oxide)) and gas\$2 and scharge or static) and (varium or exhaust) and conduct\$3 and ground\$2	USPAT; US-PGPUB	0000/06/18 18:06
-	1	©106630.pn.	USPAT; US-PGPUB	.00. 107 23 13:12
-	1	5879450.pm.	USPAT; US-FGPUB	200. 07 23 16:08
-)	h011011/\$.ipc. and (wirk or susceptor or redestal) with conduct\$4 with (film or layer) and dechuck\$4	JEO; DEFWENT	.01. 07 23 16:27
-	ı)	(h011031/\$.ipc. and (work or susceptor or pedestal) with conduct\$4 with (film or layer)) and dechuck\$4	JPO; DEFWENT	200.707723 16:29
-	302	h011021:\$.ipc. and (work or susceptor or pedestal: with conduct\$4 with (film or layer:	JEO; DEFWENT	2007 07 33 15:30
-	285	<pre>sh011001/\$.ipc. and (work or susceptor or pedestal) with conduct\$4 with (film or layer)) and @ad<2000c522</pre>	JPO; DEHWENT	1001.077.14 12:43
-	28%	<pre>(h011021/\$.ipc. and (work or susceptor or pedestal with conduct\$4 with (film or layer)) and @ad<20000500</pre>	JPO; DEFWENT	2000/07/24 10:29
-	1	<pre>((133:016/\$.ipc. and (work or susceptor or pedestal) with conduct\$4 with (film or layer:) and @ad<20000512) not ((h011031/\$.ipc. and :work or susceptor or pedestal) with conduct\$4 with (film or layer:) and @ad<20000522)</pre>	JPO; DEFWENT	2)0.2107 (24 10:3)
-	37	((tokyo adj electron).as.) and (susceptor or pedestal or work or substrate) and conduct\$4 and ground\$3 and static	USFAT; US-PGFUB	2000-07:04 10:52
_	209	118/\$.ccls. and (work or susceptor or pedestal or substrate) and conduct\$4 and static and ground\$3	USFAT; US-PGFUB	200. 07 24 11:54
-	22	"10070151"	JPO; Deswent	. 100. 07 24 11:46
-	2	"10116888"	JPO; DEFWENT	. 0.02 - 0.7 / 1.4 11:49
_		(c03c016/\$.ipc. and (work or susceptor or pedestal) with conduct\$4 with (film or layer)) and @ad<20000500	JPO; DERWENT	2001.707724 10:54
-		"02949722"	JPO; Defwent	7002447 04 12:55
-		156/345.51.ccls.	USFAT; US-PGFUB	0000707/04 13:14
_		15k-345.51.dcls. and @ad<20000522	USPAT; US-PGFUB	1901-97 34 13:18
-		(156/345.51.ccls. and @adk20000522) and conduct\$4	USPAT; US-PGFUB	2001/07/24 13:20
_		(156/345.51.ccls. and @ad<20000522) and conduct\$4 and ground\$3	USPAT; US-PGFUB	2002/07/34 13:20
_		(361/010-224 cdls.) and (susceptor or pedestal or work or substrate) and conduct\$4 and gas\$2 and static and ground\$3	USPAT; US-P3FUB	. 10. 17 24 13:51
-	323	<pre>(w rk in susceptor or pedestal or (substrate adj holder)) with (conduct\$4 or (conductive adj (film or layer))) and gas\$2 and static and ground\$3</pre>	USPAT; US-PGFUB	1901 97 24 14:14
-		((work or susceptor or pedestal or (substrate adj holder)) with (conduct\$4 or (conductive adj (film or layer))) and gas\$2 and static and ground\$3) and @adr20000522	USPAT; US-PGFUB	21(1)(7):24 14:15
-	1	4690230.pn.	USPAT; US-PGFUB	19C1 107, 25 12:11
-	1	48/3549.pn.	USPAT; US-PGPUB	2002/07/25 12:11